

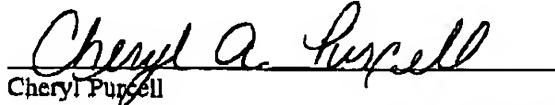
DOCKET NO: VSEA 16-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Scheuer et al.
Serial No: 10/050,743
Confirmation No: 7715
Filed: January 16, 2002
For: ADJUSTABLE CONDUCTANCE LIMITING APERTURE FOR
ION IMPLANTERS
Examiner: Savitri Mulpuri
Art Unit: 2812

#9
Ext. 1mo.
J. McMillan
7/11/03CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, Washington, D.C. 20231, on the 13th day of February, 2003.


Cheryl Purcell

FAX RECEIVED

Commissioner for Patents
Washington, D.C. 20231

JUN 16 2003

Sir:

TECHNOLOGY CENTER 2800

Petition for Extension of Time

A one-month extension of time to February 13, 2003 is requested for response to the Examiner's Office Action of December 13, 2002.

The extension fee of \$110.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

Respectfully submitted,
Scheuer et al., Applicants

By: 
Mark A. Superko, Reg. No. 34,027
Varian Semiconductor Equipment
Associates, Inc.
35 Dory Rd.
Gloucester, Massachusetts 01930-2297
Telephone: (978) 282-5915

07/14/2003 JMCILLA 00000001 500896 10050743
01 FC:1251 110.00 DA

Docket No. VSEA 16-00